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NO. 9742 P. 4

NOV 27 2006

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Venkat Selvamanickam, et al.

Title: METALORGANIC CHEMICAL VAPOR DEPOSITION (MOCVD)  
PROCESS AND APPARATUS TO PRODUCE MULTI-LAYER HIGH-  
TEMPERATURE SUPERCONDUCTING (HTS) COATED TAPE

App. No.: 10/602,468 Filed: June 23, 2003

Examiner: Aaron Austin Group Art Unit: 1775

Customer No.: 34456 Confirmation No.: 2661

Atty. Dkt. No.: 1014-SP156-US

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MS AMENDMENT  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

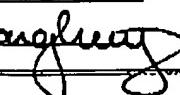
RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action mailed July 26, 2006, please amend the above-identified application as follows:

CERTIFICATE OF TRANSMISSION/MAILING	
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on <u>11-27-06</u> .	

Elise K. Dougherty  
Typed or Printed Name

  
Signature